

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Inventor: Sang Bok YUN : Confirmation No. *Not yet assigned*
U.S. Patent Application No.: *Not yet assigned* : Group Art Unit: *Not yet assigned*
Filed: *Herewith* :
For: SEMICONDUCTOR LASER DEVICE AND METHOD FOR MANUFACTURING
THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

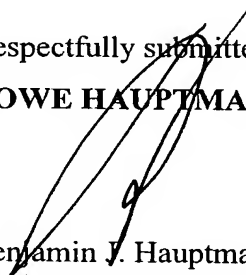
Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 2336-258		U.S. APPLICATION NO. Not yet assigned	
				APPLICANT Sang Bok YUN			
				FILING DATE herewith		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	6,025,207	02/2000	Mersali et al.				
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	<div style="text-align: center; font-size: small;">Translation</div> <div style="display: flex; justify-content: space-between; font-size: x-small;"> Yes No </div>	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.